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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/643,638	08/18/2003	Peng Zhou	COOL-01500	4432
28960	7590	09/05/2006	EXAMINER	
HAVERSTOCK & OWENS LLP 162 NORTH WOLFE ROAD SUNNYVALE, CA 94086				EARLY, MICHAEL JACOBY
ART UNIT		PAPER NUMBER		
3744				

DATE MAILED: 09/05/2006

Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Summary	Application No.	Applicant(s)
	10/643,638	ZHOU ET AL.
Examiner	Art Unit	
Michael J. Early	3744	

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

1) Responsive to communication(s) filed on 12 June 2006.

2a) This action is **FINAL**. 2b) This action is non-final.

3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

4) Claim(s) 1-32 is/are pending in the application.
4a) Of the above claim(s) _____ is/are withdrawn from consideration.

5) Claim(s) _____ is/are allowed.

6) Claim(s) 1-32 is/are rejected.

7) Claim(s) _____ is/are objected to.

8) Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

9) The specification is objected to by the Examiner.

10) The drawing(s) filed on _____ is/are: a) accepted or b) objected to by the Examiner.

 Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).

 Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).

11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

Priority under 35 U.S.C. § 119

12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
a) All b) Some * c) None of:
1. Certified copies of the priority documents have been received.
2. Certified copies of the priority documents have been received in Application No. _____.
3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

* See the attached detailed Office action for a list of the certified copies not received.

Attachment(s)

1) Notice of References Cited (PTO-892) 4) Interview Summary (PTO-413)
2) Notice of Draftsperson's Patent Drawing Review (PTO-948) Paper No(s)/Mail Date. ____.
3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)
Paper No(s)/Mail Date 6/26/06; 7/31/06. 5) Notice of Informal Patent Application (PTO-152)
6) Other: ____.

DETAILED ACTION

This Office Action is in response to the Appeal Brief filed on 6/12/06. Upon review of the Applicant's remarks in the Appeal Brief, prosecution of this application has been reopened.

Claim Rejections – 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which form the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

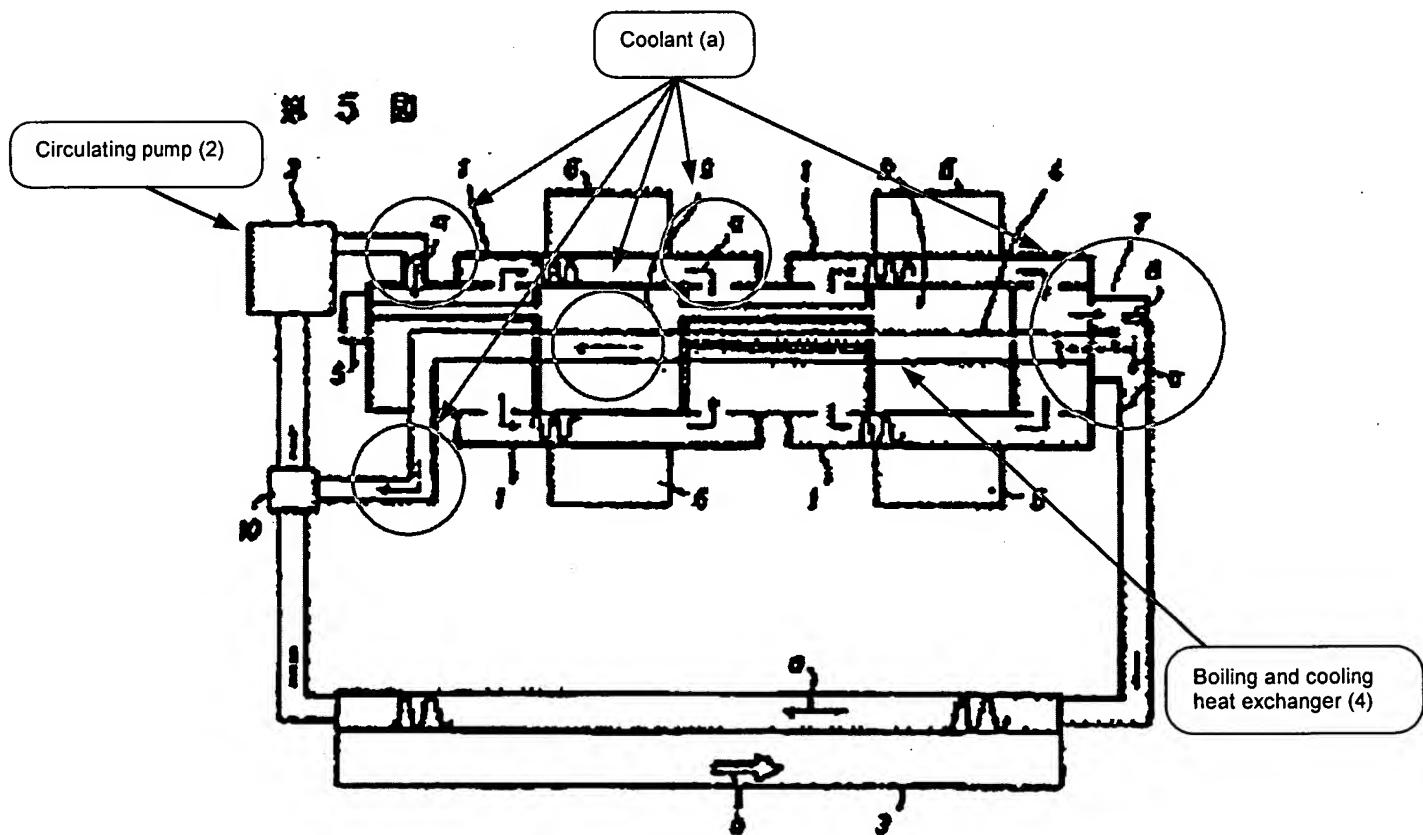
Claims 1 and 4 are rejected under 35 U.S.C. 103(a) as being unpatentable over Koo et al. ("Modeling of Two-phase microchannel Heat Sinks for VLSI Chips"), in view of Yamaguchi (JP 01-256775).

Koo et al. discloses applicant's basic inventive concept, a method of cooling a heat-generating device (IC Chip, Figure 1), using a pump (Electrokinetic pump, Figure 1) to cause a fluid flow in a heat exchanger (Microchannel Heat Exchanger, Figure 1) and having a heat rejector (Condenser, Figure 1) for rejecting heat from the system, located downstream from the heat exchanger. Koo et al. further disclose that both the pressure drop and pump power are dependent upon the mass flowrate of the flowing fluid within the system (see page 425, last paragraph).

Koo et al. do not expressly disclose:

- Adjust of the refrigerant's pressure and details related thereto.

Yamaguchi teaches that adjusting the pressure of the refrigerating fluid in the heat exchanger will correspondingly adjust the boiling point temperature of the refrigerant for evaporation cooling, via a relief valve (5), to be old in the refrigeration art (see constitution; English translation of Yamaguchi, page 4, paragraph 3; Figure 5). Yamaguchi further disclose that the circulated coolant (a) is pumped, via circulating pump (2), through the boiling and cooling heat exchanger (4), therefore making the system an "active" cooling system (see English translation of Yamaguchi; page 2, line 1 – page 3, line 3; illustration of Figure 5 below).



Regarding claim 1, it would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the system of Koo et al. by adjusting the pressure of the refrigerating fluid to correspondingly adjust the boiling point temperature of the refrigerant, as taught by Yamaguchi, in order to provide efficient cooling of the system and permit higher fluid temperatures, which in turn would maximize the heat exchanging capability of the apparatus (see Constitution).

Claims 2, 27 and 28 rejected under 35 U.S.C. 103(a) as being unpatentable over Koo et al., in view of Yamaguchi, as applied to claim 1 above, and further in view of Takahashi et al. (U.S. 6,182,742).

Koo et al. in view of Yamaguchi do not expressly disclose:

- the pressure of the refrigerating fluid is adjusted in the system by adjusting the operating conditions of the pump in response to the change in the temperature of the fluid.

Takahashi et al. teach of adjusting pressure of the refrigerating fluid in a cooling apparatus (1000) by adjusting the operating conditions of the pump (1110A) in response to the change in the temperature of the fluid to be cold in the refrigeration art (see col. 7, lines 15-22; col. 8, lines 12-18). Takahashi et al. further disclose that temperature detectors (1300A, 1300B) are positioned on a distribution header (1200), which is in fluid communication with the apparatus' heat exchangers (1120A, 1120B) (as seen in Figure 1).

Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the system of Koo et al. in view of Yamaguchi by adjusting the operating conditions of the pump in response to the change in the temperature of the fluid, as taught by Takahashi, in order to adjust the pressure of the refrigerating fluid in the system prior to it entering the heat exchangers.

Claims 3, 14-21, 26, 31 and 32 are rejected under 35 U.S.C. 103(a) as being unpatentable over Koo et al., in view of Yamaguchi, as applied to claim 1 above, and further in view of Wightman (U.S. 2003/0121274).

Koo et al. in view of Yamaguchi do not expressly disclose:

- the pressure of the refrigerating fluid is adjusted in the system by adjusting an orifice coupled to the heat exchanger in response to the change in the temperature of the fluid.

Wightman shows adjusting pressure of the refrigerating fluid in the system by adjusting an orifice (18, Figure 1) coupled to the heat exchanger (14, Figure 1) in response to the change in the temperature of the fluid (32) to be old in the refrigeration art.

Regarding claims 3, 31 and 32; it would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the system of Koo et al. in view of Yamaguchi by adjusting pressure of the refrigerating fluid in the system by adjusting an orifice coupled to the heat exchanger prior to it entering the heat exchanger, but based on the temperature of the fluid after the heat exchanger with the heat generating device, as taught by Wightman, in order to have a precise and rapid response of the orifice to variations in volumetric expansion rate [0005].

Also, Koo et al. in view of Yamaguchi do not disclose a particular type of refrigerant used, be it water, trichlorofluoromethane (R-23), pentafluoromethane (R-125), a zeotropic blend comprising R-404a, an azeotropic blend consisting of R-500 and R-502, or ammonia, as claimed by the applicant. Wightman shows that water, trichlorofluoromethane (R-23), pentafluoromethane (R-125), a zeotropic blend comprising R-404a, an azeotropic blend consisting of R-500 and R-502, or ammonia (0046), to be refrigerants common in the refrigeration art.

Regarding claims 14-21 and 26, it would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the system of Koo et al. in view of Yamaguchi, by specifying the type of refrigerant used, as taught by Wightman, in order to make the product more user- and environment-friendly.

Claims 5-7 and 9-11 are rejected under 35 U.S.C. 103(a) as being unpatentable over Koo et al., in view of Yamaguchi, as applied to claim 1 above, and further in view of Tilton et al. (U.S. 2004/0089008).

Koo et al. in view of Yamaguchi do not expressly disclose:

- the use of a reservoir to accommodate gas generated during boiling and reduce the change in pressure, said reservoir being downstream from the heat rejector and upstream from the pump.

Tilton et al. teach the use of a reservoir (25, Figure 2) to accommodate gas generated during boiling and reduce the change in pressure, said reservoir being downstream from the heat rejector (30, Figure 2) and upstream from the pump (40, Figure 2) to be old in the refrigeration art. Also, since the reservoir is used to store the vapor, it would be an obvious design choice to have such tank at a sufficient volume to contain the maximum amount of gas generated in the heat exchanger. Finally, the applicant is reminded that the use of a one piece construction instead of the structure disclosed in Tilton et al. would be merely a matter of obvious engineering choice, *In re Larson*, 340 F.2d 965, 968, 144 USPQ 347, 349 (CCPA 1965).

Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the system of Koo et al. in view of Yamaguchi, by using a reservoir, integral with the heat rejector and the pump, as taught by Tilton et al., to accommodate gas generated during boiling in order to reduce the change in pressure and prevent possible pump cavitation [0053].

Claim 8 is rejected under 35 U.S.C. 103(a) as being unpatentable over Koo et al., in view of Yamaguchi, as applied to claim 1 above, and further in view of Tilton et al., as applied to claim 5 above and still further in view of Cowans (U.S. 6,775,996).

Koo et al. in view of Yamaguchi and further in view of Tilton et al. do not expressly disclose:

- the reservoir is upstream of the heat rejector.

Cowans teaches the use of a reservoir (92, Figure 2) to accommodate gas generated during boiling, said reservoir being upstream from the heat rejector (44, Figure 2) to be old in the refrigeration art.

Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the system of Koo et al. in view of Yamaguchi and further in view of Tilton et al., by using a reservoir to accommodate gas generated during boiling upstream of the heat rejector, as taught by Cowans, in order to use the gas as a heat exchanging fluid for another purpose (subcooler 52, Figure 2).

Claims 12 and 13 are rejected under 35 U.S.C. 103(a) as being unpatentable over Koo et al., in view of Yamaguchi, as applied to claim 1 above, and further in view of Chesson et al. (U.S. 2004/0040695).

Koo et al. in view of Yamaguchi do not expressly disclose:

- the system is hermetically sealed, where the pressure varies less than 1 psi during a five year lifetime.

Chesson et al. teach the use of a hermetically sealed pumped loop cooling system [0042] to be old in the refrigeration art. Also, any hermetically sealed system is completely sealed, which provides no variations in the pressure, including a change in pressure of 1 psi.

Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the system of Koo et al. in view of Yamaguchi, by using a hermetically sealed pumped loop cooling system, as taught by Chesser et al., in order to prevent outside elements from factoring in the cooling variations and the systems performance (sub-atmospheric conditions, [0042]).

Claims 22-25 are rejected under 35 U.S.C. 103(a) as being unpatentable over Koo et al., in view of Yamaguchi, as applied to claim 1 above, and further in view of Gold (U.S. 6,023,934).

Koo et al. in view of Yamaguchi do not expressly disclose:

- a particular type of refrigerant used, be it a hydrocarbon like methane, or a cryogenic like helium.

Gold teaches the use of a hydrocarbon like methane (see col. 4, line 12), or a cryogenic like helium (see col. 1, lines 18-19) as a refrigerant to be old in the refrigeration art.

Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the system of Koo et al. in view of Yamaguchi, by specifying the type of refrigerant used, as taught by Gold, in order to make the product more user- and environment-friendly.

Claims 29 and 30 are rejected under 35 U.S.C. 103(a) as being unpatentable over Koo et al., in view of Yamaguchi, as applied to claim 1 above, and further in view of Jiang et al. ("A Closed-Loop Electroosmotic Microchannel Cooling System for VLSI Circuits").

Koo et al. in view of Yamaguchi do not expressly disclose:

- using an electroosmotic pump as pumping means and a catalytic recombiner, coupled to the inlet port of the pump, wherein the hydrogen and oxygen are combined to produce water.

Jiang et al. teach the use of an electroosmotic pump (see page 4, lines 6-8) as pumping means and a catalytic recombiner (as seen in Figure 8) to be old in the refrigeration art.

Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the system of Koo et al. in view of Yamaguchi, by using an electroosmotic pump as pumping means, as taught by Jiang et al., since electroosmotic pumps do not require any movable parts and are very compact (see page 4, line 8), and a catalytic recombiner, coupled to the inlet port of the pump in order to recombine the gas during electrolysis (see page 9, lines 1 – 2).

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Michael J. Early whose telephone number is (571) 272-3681. The examiner can normally be reached on Monday - Friday, 7am - 4:30pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Cheryl Tyler can be reached on (571) 272-4834. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

MJE
8/30/06

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